

Docket No.: 212835US2PCT/smc



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Michio SATO, et al.

SERIAL NUMBER: 09/926,041

GROUP: 1753

FILED: August 20, 2001

EXAMINER: MCDONALD, RODNEY GLENN

FOR: COMPONENTS FOR VACUUM DEPOSITION APPARATUS AND VACUUM  
DEPOSITION APPARATUS THEREWITH, AND TARGET APPARATUS

**REQUEST TO CORRECT FIRST INVENTOR'S NAME**

MAIL STOP ISSUE FEE  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

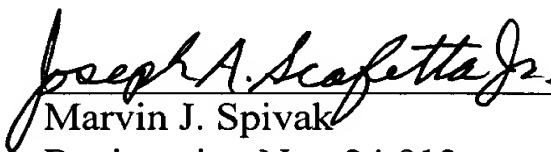
SIR:

In the matter of the above-identified application, we hereby request correction of your records to reflect the correct spelling of the first inventor's name.

The first inventor's name should be: Michio SATO

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.

  
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